

Gaussian Process Landmarking on Manifolds

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"Geometry and Learning from Data in 3D and Beyond" Workshop II: Shape Analysis
Institute for Pure and Applied Mathematics
Los Angeles, CA

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Outline

Motivation

- ▶ Geometric Morphometrics
- ▶ Experimental Design

Gaussian Process Landmarking

- ▶ Sequential Experimental Design
- ▶ Witten Laplacian
- ▶ Reduced Basis Method

Other Applications

Joint work with **Shahar Z. Kovalsky, Doug M. Boyer, Ingrid Daubechies**

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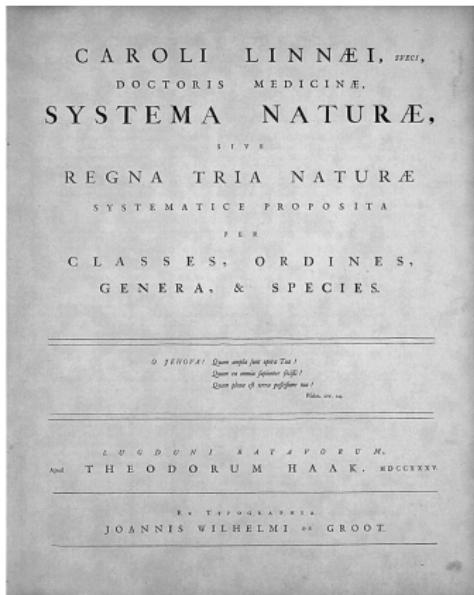
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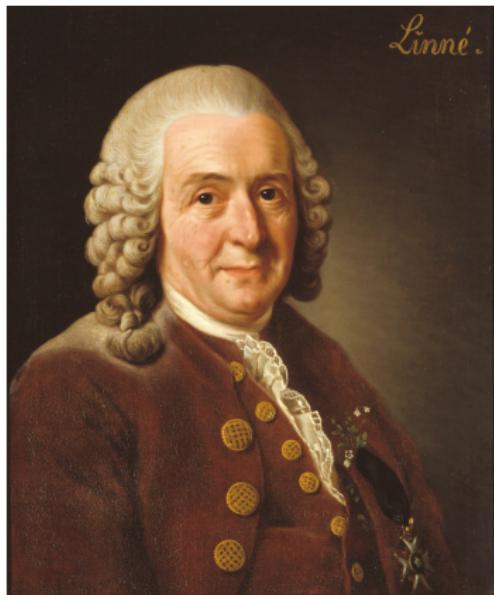
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Morphology and Classification



Systema Naturae, 1735



Carl Linnaeus (1707-1778)

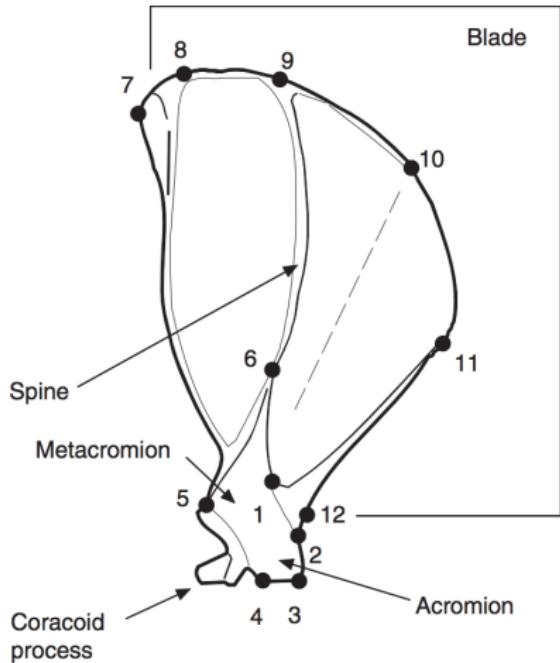
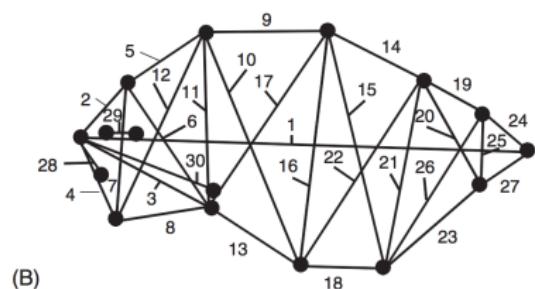
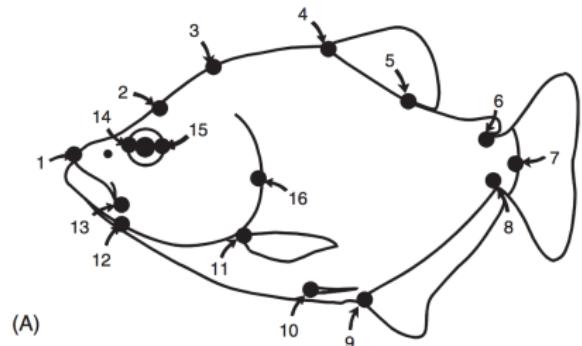
Iris — A Classical Example of Morphometrics



Iris setosa				Iris versicolor				Iris virginica			
Sepal length	Sepal width	Petal length	Petal width	Sepal length	Sepal width	Petal length	Petal width	Sepal length	Sepal width	Petal length	Petal width
5.1	3.5	1.4	0.2	7.0	3.2	4.7	1.4	6.3	3.3	6.0	2.5
4.9	3.0	1.4	0.2	6.4	3.2	4.5	1.5	5.8	2.7	5.1	1.9
4.7	3.2	1.3	0.2	6.9	3.1	4.9	1.5	7.1	3.0	5.9	2.1
4.6	3.1	1.5	0.2	5.5	2.3	4.0	1.3	6.3	2.9	5.6	1.8
5.0	3.6	1.4	0.2	6.5	2.8	4.6	1.5	6.5	3.0	5.8	2.2
5.4	3.9	1.7	0.4	5.7	2.8	4.5	1.3	7.6	3.0	6.6	2.1
4.6	3.4	1.4	0.3	6.3	3.3	4.7	1.6	4.9	2.5	4.5	1.7
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- R.A. Fisher. "The Use of Multiple Measurements in Taxonomic Problems." *Annals of Eugenics* 7.2 (1936): 179–188.

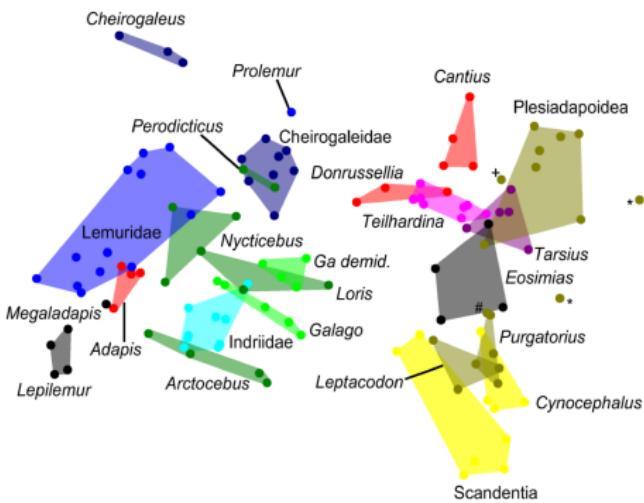
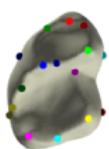
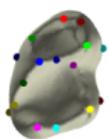
Landmark-based Geometric Morphometrics



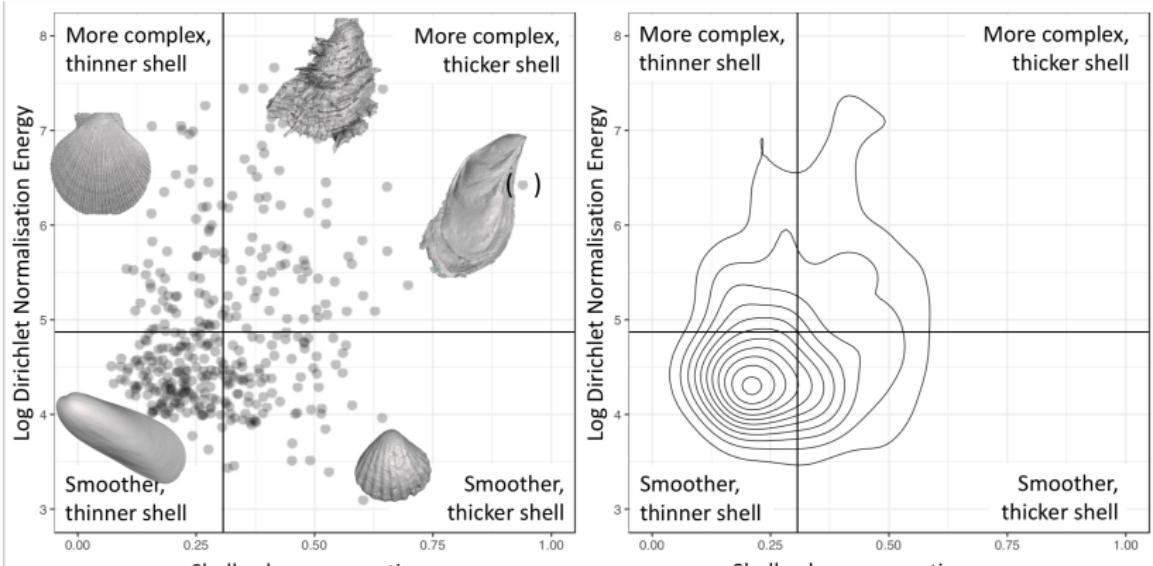
Geometric Morphometrics

$$\left(S_1, \{x_j\}_{j=1}^J\right), \left(S_2, \{y_j\}_{j=1}^J\right) \rightarrow$$

$$d_{Procrustes}^2(S_1, S_2) = \min_{R \text{ rigid motion}} \frac{1}{J} \sum_{j=1}^J \|R(x_j) - y_j\|^2$$



- Boyer et al. "Algorithms to Automatically Quantify the Geometric Similarity of Anatomical Surfaces." *Proceedings of the National Academy of Sciences* 108.45 (2011): 18221–18226.



Shape Distances

- ▶ John Clifford Gower, John C. Gower, and Garnt B. Dijksterhuis. "**Procrustes Problems.**" vol. 3 of Oxford Statistical Science Series, Oxford University Press Oxford, 2004.
- ▶ Rima Alaifari, Ingrid Daubechies, and Yaron Lipman. "**Continuous Procrustes distance between two surfaces.**" *Communications on Pure and Applied Mathematics* 66, no. 6 (2013): 934-964.
- ▶ Doug M. Boyer, Yaron Lipman, Elizabeth St Clair, Jesus Puente, Biren A. Patel, Thomas Funkhouser, Jukka Jernvall, and Ingrid Daubechies. "**Algorithms to automatically quantify the geometric similarity of anatomical surfaces.**" *Proceedings of the National Academy of Sciences* 108, no. 45 (2011): 18221-18226.
- ▶ Facundo Mémoli. "**Gromov-Wasserstein distances and the metric approach to object matching.**" *Foundations of Computational Mathematics* 11, no. 4 (2011): 417-487.
- ▶ Rongjie Lai, Hongkai Zhao. "**Multi-scale Non-Rigid Point Cloud Registration Using Robust Sliced-Wasserstein Distance via Laplace-Beltrami Eigenmap**", *SIAM Journal on Imaging Sciences* 10(2), pp. 449-483, 2017.
- ▶ Patrice Koehl, Joel Hass, "**Landmark-Free Geometric Methods in Biological Shape Analysis**", *Journal of The Royal Society Interface*, 12 no. 113 (2015): 20150795
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Shape Distances

Boyer et al. 2011, 2012

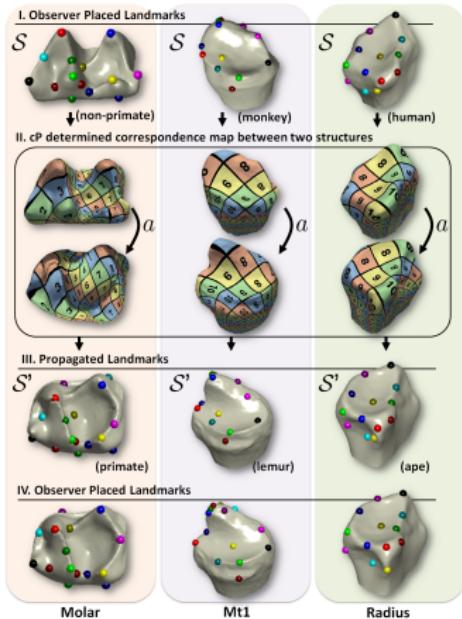
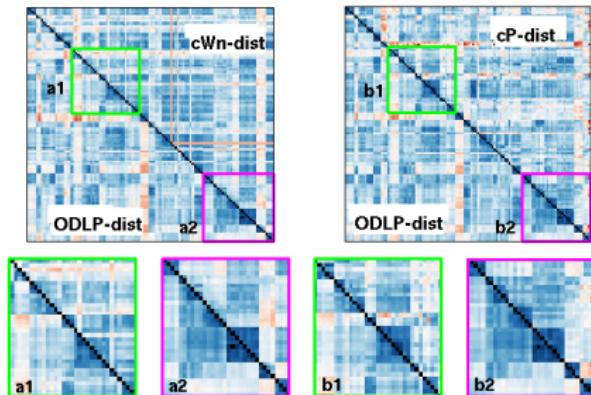
Daubechies et al. 2011, 2013

Al-Aifari et al. 2013

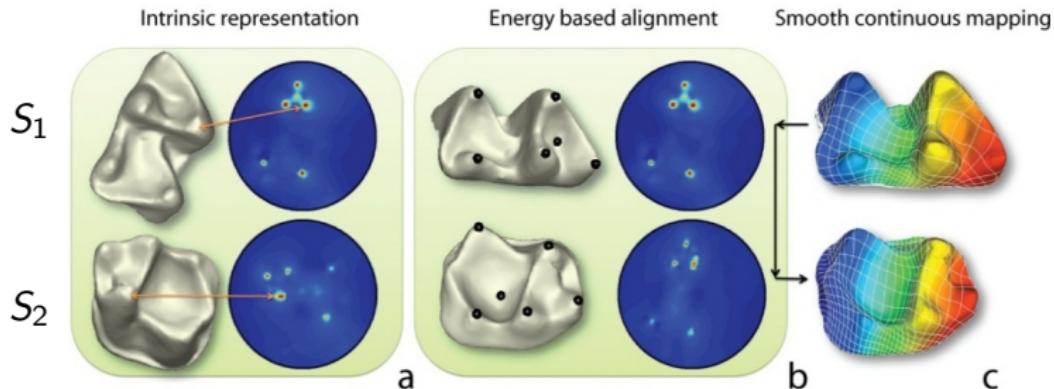
Conformal Wasserstein Distance

Continuous Procrustes Distance

$$d_{\text{CP}}(S_1, S_2) = \inf_{\mathcal{C} \in \mathcal{A}(S_1, S_2)} \inf_{R \in \mathbb{R}(3)} \left(\int_{S_1} \|R(x) - \mathcal{C}(x)\|^2 d\text{vol}_{S_1}(x) \right)^{\frac{1}{2}}$$



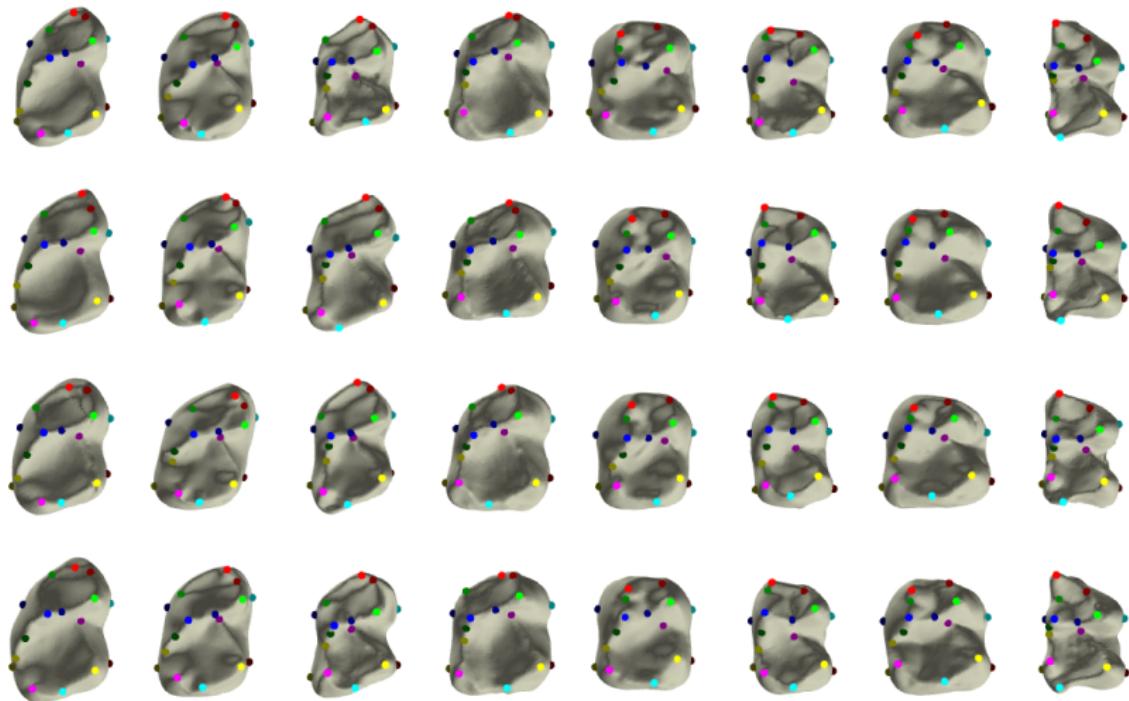
Landmark-Free Approaches: Bypass Feature Extraction



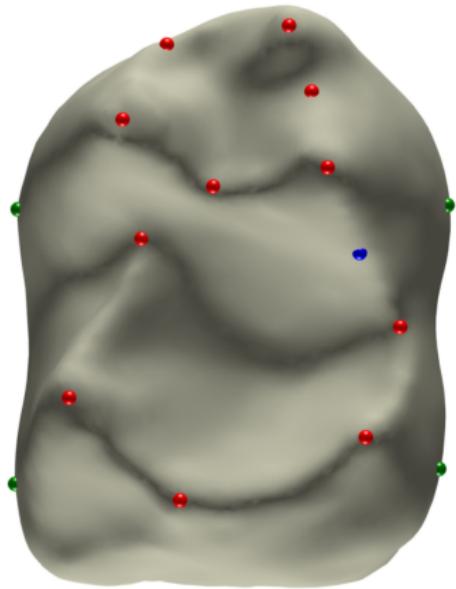
Correspondence-Based Shape Distances

$$D(S_1, S_2) = \inf_{f \in \mathcal{A}(S_1, S_2)} F(f; S_1, S_2)$$

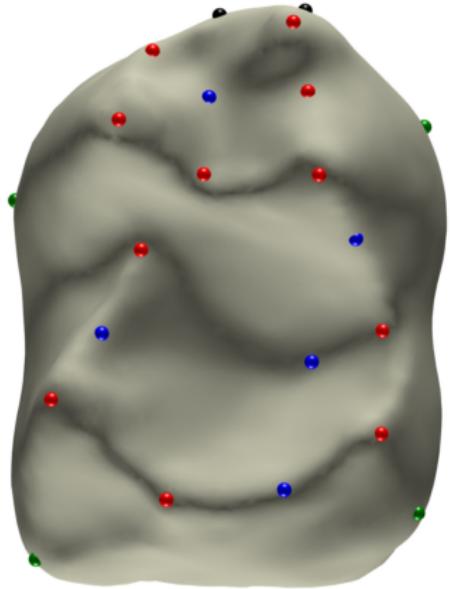
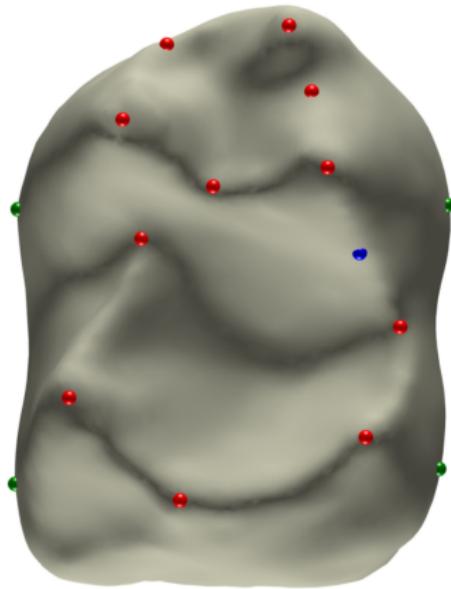
Revisiting Landmarks: For the Sake of Interpretability, or Turning the Clock Back?



Bookstein's Typology



Bookstein's Typology Cracked?



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Experimental Design: A Classical Paradigm in Statistics

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- ▶ **Inference:** Given i.i.d. data $\{(X_i, Y_i), 1 \leq i \leq n\}$ sampled from a joint distribution \mathcal{D} , find good estimators by solving

$$\min_{\hat{f} \in \mathcal{F}} \mathbb{E}_{(X, Y) \sim \mathcal{D}} \left[\left(\hat{f}_n(X | \{(X_i, Y_i)\}) - Y \right)^2 \right]$$

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- ▶ **Experimental Design:** Given an estimation procedure $f \mapsto \hat{f}_n$ for a class of target functions $f \sim \mathcal{F}$, find samples x_1, \dots, x_n that minimize

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- ▶ **Gaussian Process Experimental Design:** $\mathcal{F} = \text{GP}(m, K)$ is a **Gaussian process** on domain \mathcal{X}

Gaussian Process Experimental Design: (Simple) Kriging

- ▶ Gaussian process $\text{GP}(0, K)$ defined on a domain Ω by
 - ▶ **kernel function** $K : \Omega \times \Omega \rightarrow \mathbb{R}$
 - ▶ For $f \sim \text{GP}(0, K)$, its values at any n points $x_1, \dots, x_n \in \Omega$

$$(f(x_1), \dots, f(x_n))^\top \in \mathbb{R}^n$$

follow a multivariate normal distribution

$$\mathcal{N}(0, \mathcal{K}_n)$$

where

$$\mathcal{K}_n = \begin{pmatrix} K(x_1, x_1) & \dots & K(x_1, x_n) \\ \vdots & & \vdots \\ K(x_n, x_1) & \dots & K(x_n, x_n) \end{pmatrix} \in \mathbb{R}^{n \times n}$$

Gaussian Process Experimental Design: (Simple) Kriging

- ▶ Conditioned on values at x_1, \dots, x_n , i.e.

$$f(x_i) = y_i, \quad 1 \leq i \leq n,$$

the value $f(x)$ at any new point $x \in \Omega$ follows a normal distribution

$$\begin{aligned} f(x) | \{f(x_i) = y_i, 1 \leq i \leq n\} \\ \sim \mathcal{N} \left(\mathbf{r}_n(x)^\top \mathcal{K}_n^{-1} \mathbf{y}, K(x, x) - \mathbf{r}_n(x)^\top \mathcal{K}_n^{-1} \mathbf{r}_n(x) \right) \end{aligned}$$

where

$$\begin{aligned} \mathbf{r}_n(x) &= (K(x, x_1), \dots, K(x, x_n))^\top \in \mathbb{R}^n \\ \mathbf{y} &= (y_1, \dots, y_n)^\top \in \mathbb{R}^n. \end{aligned}$$

Gaussian Process Experimental Design: (Simple) Kriging

- ▶ Mean Squared Error (**MSE**) of the predictor

$$\begin{aligned}\hat{f}_n(x) &= \mathbb{E}(f(x) \mid \{f(x_i) = y_i, 1 \leq i \leq n\}) \\ &= \mathbf{r}_n(x)^\top \mathcal{K}_n^{-1} \mathbf{y}\end{aligned}$$

is simply

$$\begin{aligned}\text{MSE}(\hat{f}_n(x)) &= \mathbb{E}(\hat{f}_n(x) - f(x))^2 \\ &= K(x, x) - \mathbf{r}_n(x)^\top \mathcal{K}_n^{-1} \mathbf{r}_n(x)\end{aligned}$$

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- ▶ **Kriging:** How to pick $x_1, \dots, x_n \in M$ so as to minimize the Integrated MSE (**IMSE**)

$$\text{IMSE}(\hat{f}_n) := \int_{\Omega} \text{MSE}(\hat{f}_n(x)) dx$$

Universal Convergence of (Simple) Kriging

Spectral Convergence (Wang-Tuo-Wu 2017). If K is a Gaussian kernel, $\{x_1, \dots, x_n\} \subset \Omega$ a bounded open subset of a Euclidean space, then w.h.p.

$$\sup_{x \in \Omega} \left| \hat{f}_n(x) - f(x) \right| = O_P \left(h_n^{\frac{c}{h_n} - \frac{1}{2}} \log^{\frac{1}{2}} (1/h_n) \right)$$

where h_n is the *fill distance*

$$h_n := \sup_{x \in \Omega} \min_{1 \leq i \leq n} \|x - x_i\|.$$

Corollary. Let h_* denote the minimum fill distance on Ω for n points. Then

$$\inf_{\{x_1, \dots, x_n\} \subset \Omega} \text{IMSE} \left(\hat{f}_n \right) = O_P \left(h_*^{\frac{c}{h_*} - 1} \log (1/h_*) \right).$$

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- ▶ **Numerical Linear Algebra Perspective:** Cholesky Decomposition with Complete Pivoting

Gaussian Process Landmarking

Input: d -dimensional Manifold M isometrically embedded in \mathbb{R}^D , where $d < D$, and number of landmarks N

- ▶ Construct a kernel $K^c : M \times M \rightarrow \mathbb{R}$

$$K_\epsilon^c(x, y) = \int_M e^{-\frac{1}{2\epsilon} \|x-z\|_D^2} c(z) e^{-\frac{1}{2\epsilon} \|z-y\|_D^2} d\text{vol}_M(z)$$

where $c : M \rightarrow \mathbb{R}$ is the (Gauss/mean/ L^2 -) curvature of M

- ▶ For $i = 1$

$$x_1 = \arg \max_{x \in M} K_\epsilon^c(x, x)$$

Gaussian Process Landmarking

- ▶ For $i = 2, \dots, N$

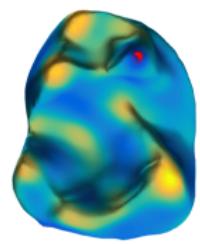
$$\begin{aligned}x_i &= \arg \max_{x \in M} \text{MSE} \left(\hat{f}_{i-1}(x) \right) \\&= \arg \max_{x \in M} \left[K_\epsilon^c(x, x) - \mathbf{r}_{i-1}^c(x)^\top \mathcal{K}_{i-1}^{-1} \mathbf{r}_{i-1}^c(x) \right]\end{aligned}$$

where

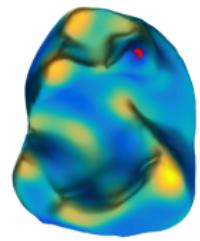
$$\begin{aligned}\mathbf{r}_{i-1}^c(x) &= (K_\epsilon^c(x, x_1), \dots, K_\epsilon^c(x, x_{i-1}))^\top \in \mathbb{R}^{i-1}, \\ \mathcal{K}_{i-1} &= \begin{pmatrix} K(x_1, x_1) & \dots & K(x_1, x_{i-1}) \\ \vdots & & \vdots \\ K(x_{i-1}, x_1) & \dots & K(x_{i-1}, x_{i-1}) \end{pmatrix} \in \mathbb{R}^{(i-1) \times (i-1)}\end{aligned}$$

Output: N landmarks $x_1, \dots, x_N \in M$

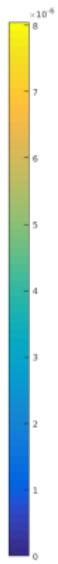
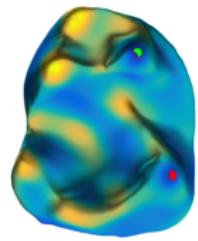
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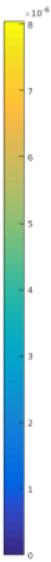


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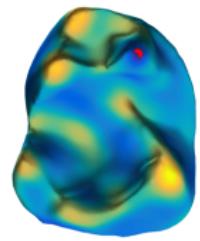


Step 2

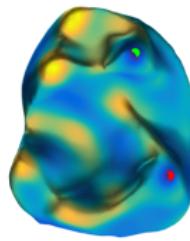




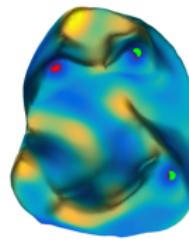
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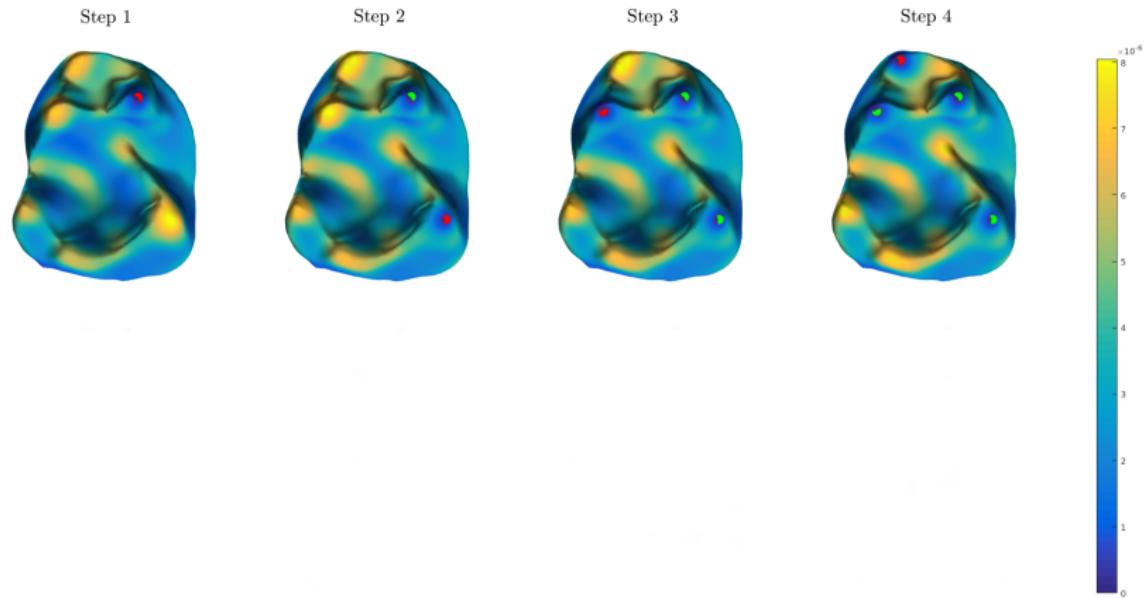


Step 2



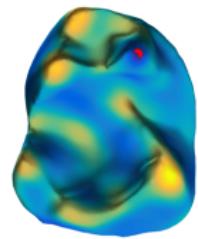
Step 3



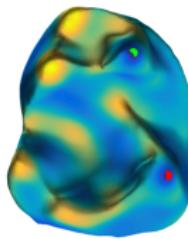




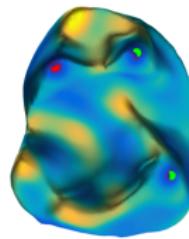
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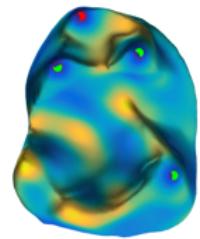
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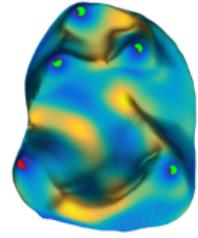
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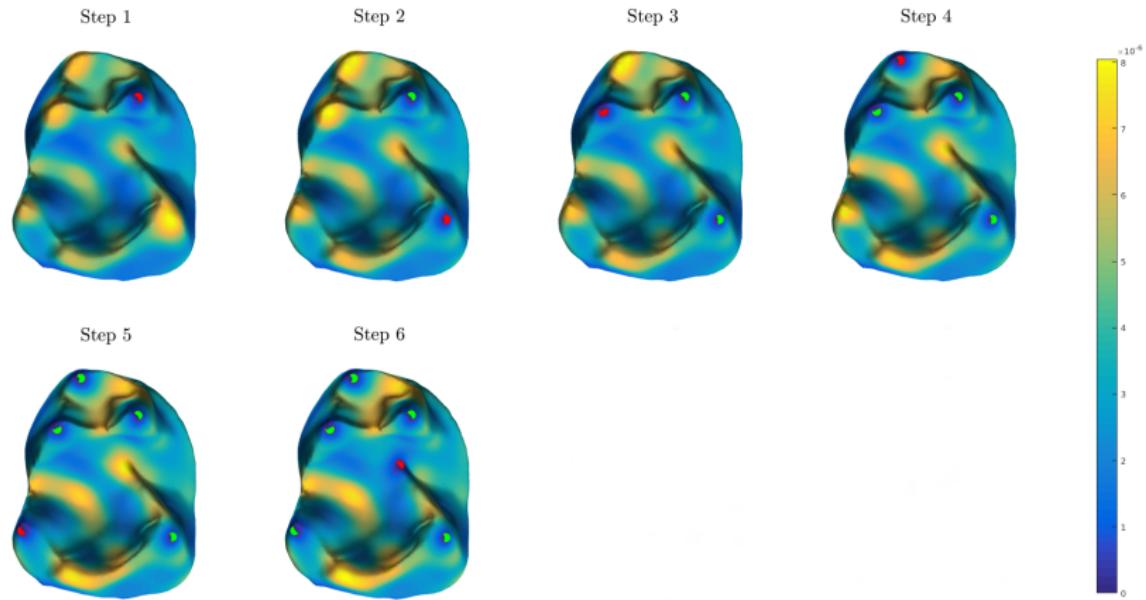


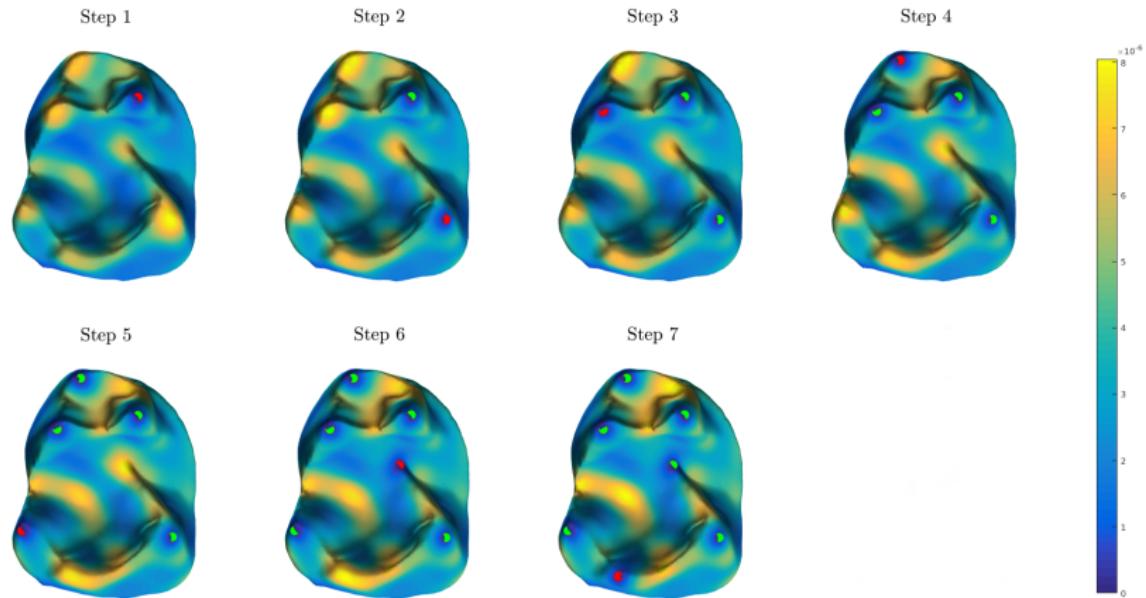
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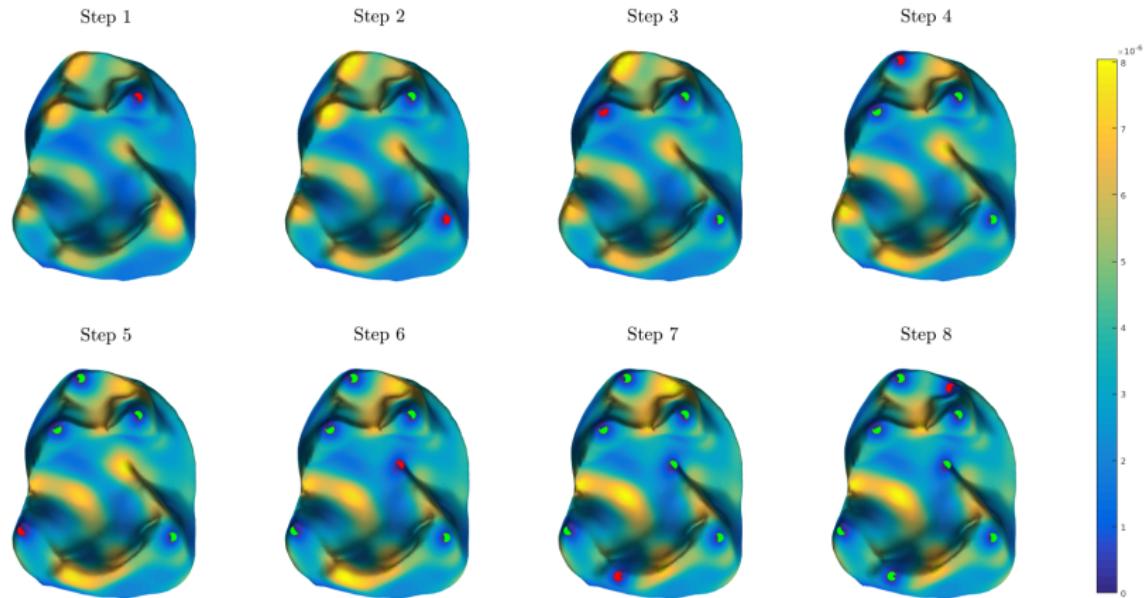


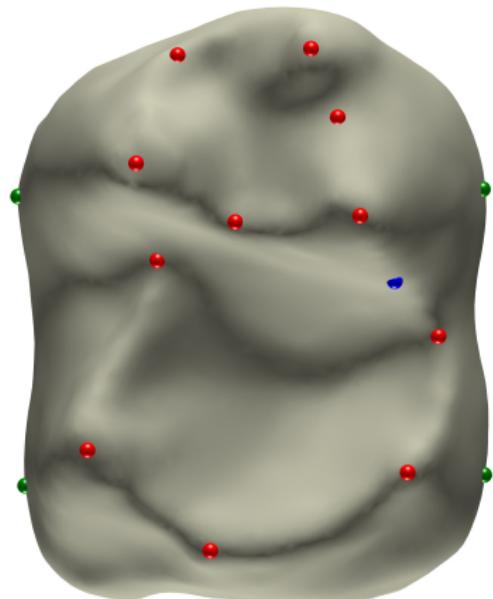
Step 5



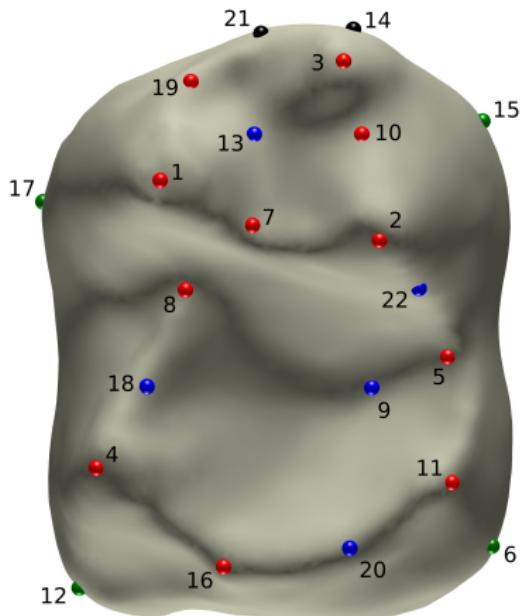






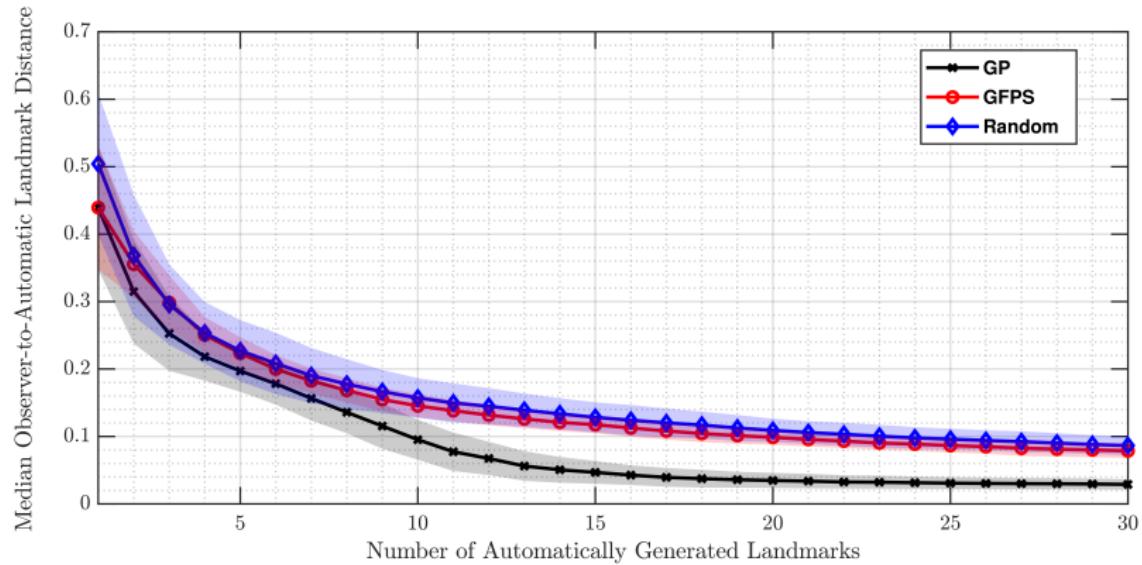


(a) Observer Landmarks

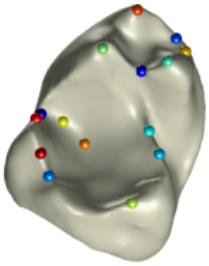
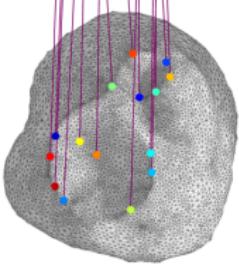
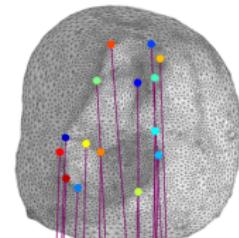
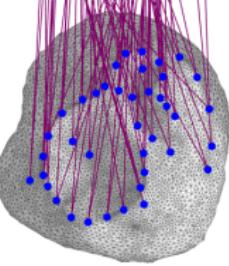
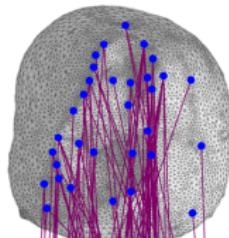
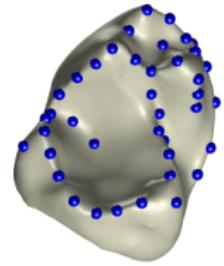
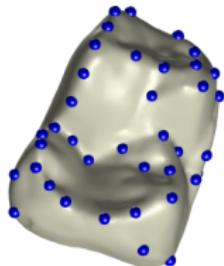


(b) First 22 Gaussian Process Landmarks

Efficient Adequate Coverage



Feature Matching by Bounded Distortion Filtering



(a)

(b)

(c)

(d)

(e)

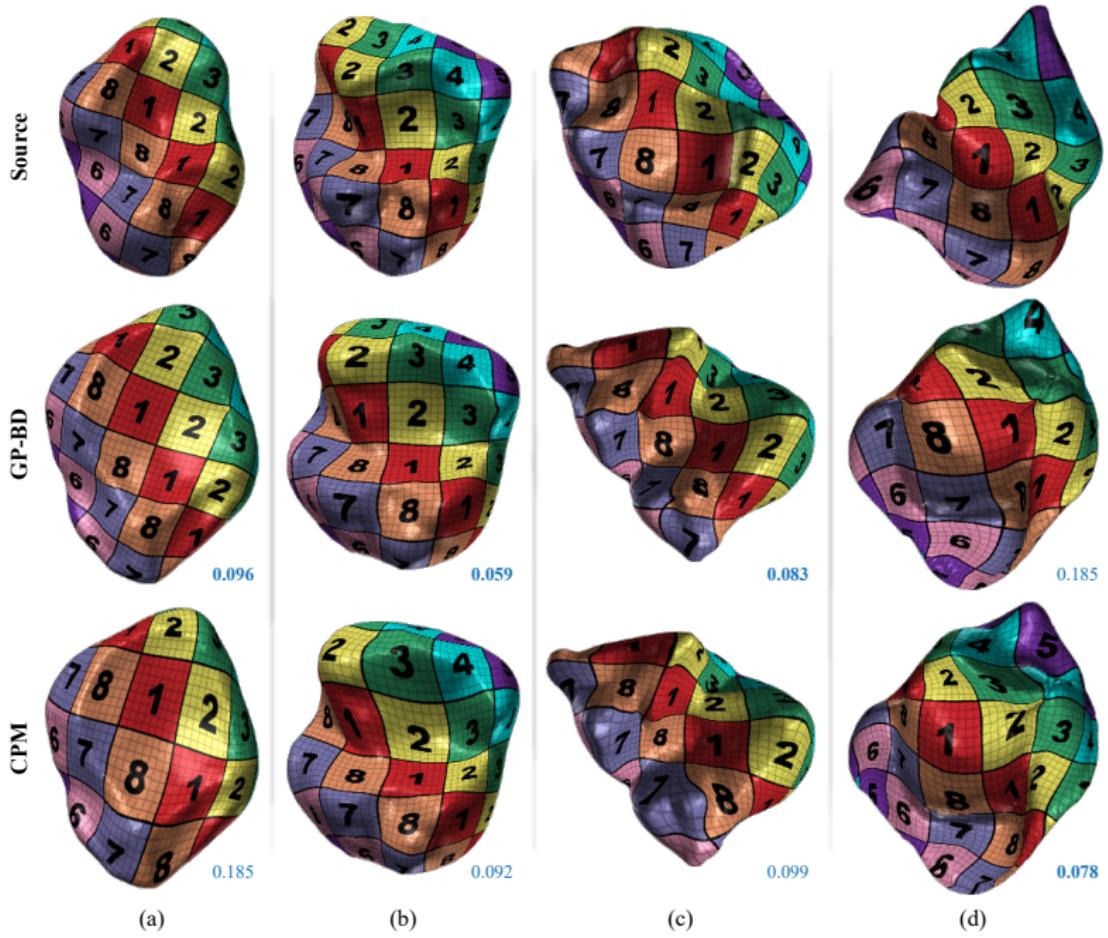
Feature Matching by Bounded Distortion Filtering

- ▶ GP landmarks $\{\zeta_1^{(1)}, \dots, \zeta_L^{(1)}\}$ on S_1 , $\{\zeta_1^{(2)}, \dots, \zeta_L^{(2)}\}$ on S_2
- ▶ For each $\zeta_\ell^{(1)}$ propose T matches $\zeta_{\ell \rightarrow 1}^{(2)}, \dots, \zeta_{\ell \rightarrow T}^{(2)}$ on S_2
- ▶ Solve the minimization problem (with *iterative reweighted least squares* (IRLS))

$$\min_{\Psi \in \mathcal{BD}(K)} \sum_{\ell=1}^L \sum_{t=1}^T \left\| \Psi \left(\zeta_\ell^{(1)} \right) - \zeta_{\ell \rightarrow t}^{(2)} \right\|^0$$

where $\mathcal{BD}(K)$ is the space of quasiconformal maps between S_1 and S_2 with conformal distortion bounded by $K \geq 1$

- Lipman, Yaron, Stav Yagev, Roi Poranne, David W. Jacobs, and Ronen Basri. "Feature Matching with Bounded Distortion." *ACM Transactions on Graphics*. 33, no. 3 (2014): 26.



Outline

Motivation

- ▶ Geometric Morphometrics
- ▶ Experimental Design

Gaussian Process Landmarking

- ▶ Sequential Experimental Design
- ▶ **Witten Laplacian**
- ▶ Reduced Basis Method

Other Applications

Joint work with **Shahar Z. Kovalsky, Doug M. Boyer, Ingrid Daubechies**

Reweighted Kernel and the Witten Laplacian

$$K_\epsilon^c(x, y) = \int_M e^{-\frac{1}{2\epsilon}\|x-z\|_D^2} c(z) e^{-\frac{1}{2\epsilon}\|z-y\|_D^2} d\text{vol}_M(z)$$

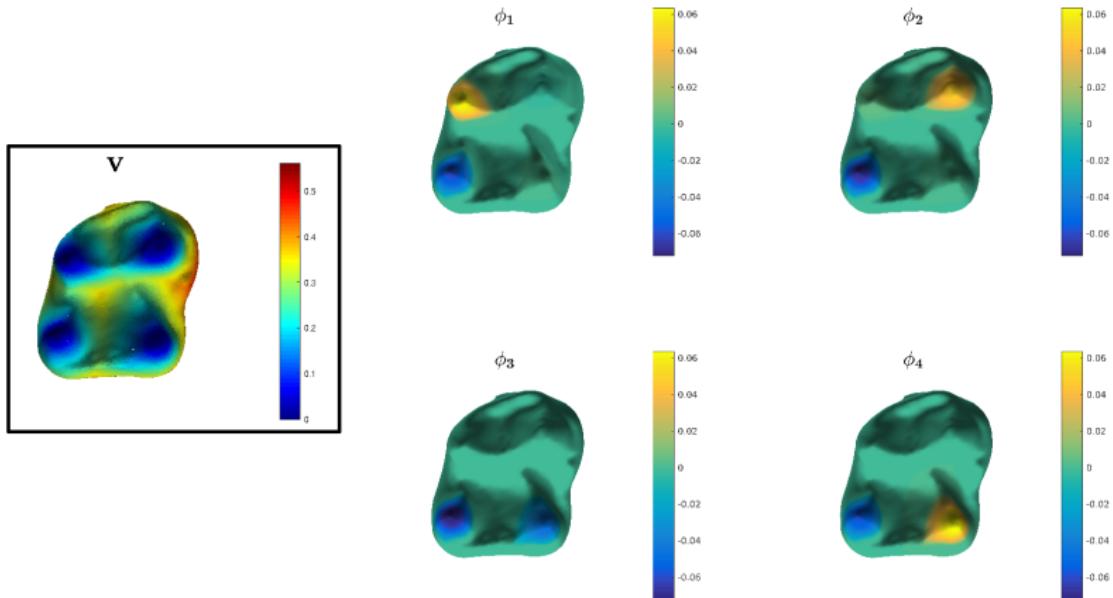
THM. (G. et al. 2019b). For $f \in C^2(M)$

$$\begin{aligned} \lim_{\epsilon \rightarrow 0} \frac{1}{\epsilon} & \left[\frac{\int_M K_\epsilon^c(x, y) f(y) d\text{vol}_M(y)}{\int_M K_\epsilon^c(x, y) d\text{vol}_M(y)} - f(x) \right] \\ &= \Delta f(x) + \nabla f(x) \cdot \nabla \log c(x). \end{aligned}$$

I.e., the infinitesimal generator of the diffusion process defined by transition kernel $K_\epsilon^c(x, y)$ is conjugate to the **Witten Laplacian**

$$L_\epsilon = -\Delta - \frac{1}{\epsilon} \nabla \log c \cdot \nabla$$

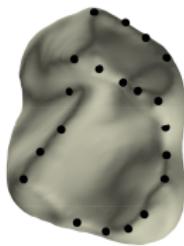
Localization of Eigenfunctions



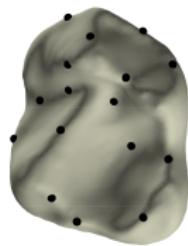
Gao et al. "Gaussian Process Landmarking for Three-Dimensional Geometric Morphometrics." SIMODS (2019)

The Importance of Reweighting

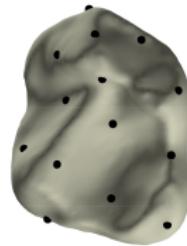
Gaussian Process Landmarking



Local Weight Maximum



Geodesic Farthest Point Sampling



Gao et al. "Gaussian Process Landmarking for Three-Dimensional Geometric Morphometrics." SIMODS (2019)

Outline

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- ▶ Geometric Morphometrics
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Gaussian Process Landmarking

- ▶ Sequential Experimental Design
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- ▶ **Reduced Basis Method**

Other Applications

Joint work with **Shahar Z. Kovalsky, Doug M. Boyer, Ingrid Daubechies**

Sequential Experimental Design: Some Theory

- ▶ **Statistically:** If problem has submodularity (e.g. maximizing $\det(\mathcal{K}_n)$ in entropy-based sequential experimental design), can obtain near-optimality [Ko et al. 1995, Kause et al. 2008, Bouhtou et al. 2010]

$$\text{OPT}_n \geq \text{GPL}_n \geq (1 - 1/e) \text{OPT}_n$$

- ▶ **Algorithmically:** This problem is NP-hard, life is short, find polynomial time approximations [Avron and Boutsidis 2013, Nikolov 2015, Wang et al. 2017, Allen-Zhu et al 2018]
- ▶ **Machine Learning:** Active Learning [Lewis and Gale 1994, Settles 2010]
- ▶ **Our Contribution:** Estimates for the decay rate of

$$\left\| \text{MSE} \left(\hat{f}_n(\cdot) \right) \right\|_{\infty} = \sup_{x \in M} \text{MSE} \left(\hat{f}_n(x) \right)$$

Faster Decay Than Any Inverse Polynomials

THM (G. et al. 2019a). Let M be a d -dimensional Riemannian manifold isometrically embedded in \mathbb{R}^D , with $d < D$. Let x_1, \dots, x_n be sequentially sampled on M using the Gaussian process landmarking algorithm. If K_ϵ^c is in $C^\ell(M)$, then for any $1 \leq k \leq \ell$ there exists $C_k > 0$ such that

$$\sup_{x \in M} \text{MSE}\left(\hat{f}_n(x)\right) \leq C_k n^{-\frac{k}{d}}$$

for all sufficiently large $n \in \mathbb{N}$.

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$$\sup_{x \in M} \text{MSE}\left(\hat{f}_n(x)\right) \leq C_k n^{-\frac{k}{d}}$$

for all sufficiently large $n \in \mathbb{N}$.

- ▶ Proof relies on the interpretation of the Gaussian process landmarking algorithm as applying the **reduced basis method** to the **reproducing kernel Hilbert space** associated with the Gaussian process $\text{GP}(0, K_\epsilon^c)$.

Gao et al. "Gaussian Process Landmarking on Manifolds." SIMODS (2019)

Reproducing Kernel Hilbert Space for Gaussian Processes

- ▶ **Mercer's Theorem:** $K_\epsilon^c(x, y) = \sum_{k=0}^{\infty} e^{-\lambda_k} \phi_k(x) \phi_k(y)$
- ▶ **RKHS:** Closure under the RKHS norm of the set

$$\left\{ \sum_{i \in I} a_i K_\epsilon^c(\cdot, z_i) \mid a_i \in \mathbb{R}, z_i \in M, \text{card}(I) < \infty \right\}$$

- ▶ **Feature Mapping:** $M \ni x \mapsto K_\epsilon^c(x, \cdot) \in \text{RKHS}$

Key Observation: If $V_n := \text{span} \{K_\epsilon^c(x_1, \cdot), \dots, K_\epsilon^c(x_n, \cdot)\}$, then

$$\text{MSE}(\hat{f}_n(x)) = \text{dist}_{\text{RKHS}}(K_\epsilon^c(x, \cdot), V_n)$$

Reduced Basis Method vs. Sequential Experimental Design

RBM	GP-SED
compact $K \subset \mathcal{H}$	compact $M^d \hookrightarrow \mathbb{R}^D$
$f_1 := \arg \max_{h \in K} \ h\ $	$x_1 := \arg \max_{x \in M} K_\epsilon^c(x, x)$
$f_2 := \arg \max_{h \in K} \text{dist}_{\mathcal{H}}(h, V_1)$ $V_1 := \text{span}\{f_0\}$	$x_2 := \arg \max_{x \in M} \text{MSE}\left(\hat{f}_1(x)\right)$
\vdots	\vdots
$f_n := \arg \max_{h \in K} \text{dist}_{\mathcal{H}}(h, V_{n-1})$ $V_{n-1} := \text{span}\{f_0, \dots, f_{n-1}\}$	$x_n := \arg \max_{x \in M} \text{MSE}\left(\hat{f}_{n-1}(x)\right)$

Key Observation: If $V_n := \text{span}\{K_\epsilon^c(x_1, \cdot), \dots, K_\epsilon^c(x_n, \cdot)\}$, then

$$\text{MSE}\left(\hat{f}_n(x)\right) = \text{dist}_{\text{RKHS}}(K_\epsilon^c(x, \cdot), V_n)$$

Greedy Algorithms in Reduced Basis Methods

$$d_n := \inf_{\substack{\dim Y = n \\ Y \subset \text{RKHS}}} \sup_{x \in M} \text{dist}_{\text{RKHS}}(K_\epsilon^c(x, \cdot), Y)$$

$$\sigma_n := \sup_{x \in M} \text{dist}_{\text{RKHS}}(K_\epsilon^c(x, \cdot), V_n)$$

- ▶ $\sigma_n = \left\| \text{MSE}(\hat{f}_n(\cdot)) \right\|_\infty$
- ▶ d_n is the **Kolmogorov width**, and $d_n = O(h_n^k)$ if M is a C^k manifold, where h_n is the **fill distance** with n points (Wendland 2004)
- ▶ Results from the reduced basis method (Binev et al. 2011, DeVore et al. 2013) can be used to obtain $\sigma_n = O(d_{\lfloor n/2 \rfloor}^{1/2})$

Greedy Algorithms in Reduced Basis Methods

Theorem (DeVore et al. 2013). For any $N \geq 0$, $n \geq 1$, and $1 \leq m < n$, there holds

$$\prod_{\ell=1}^n \sigma_{N+\ell}^2 \leq \left(\frac{n}{m}\right)^m \left(\frac{n}{n-m}\right)^{n-m} \sigma_{N+1}^{2m} d_m^{2n-2m}.$$

In particular, setting $N = 0$ and $m = \lfloor n/2 \rfloor$,

$$\sigma_n \leq \sqrt{2} \|K_\epsilon^c\|_{\infty, M \times M}^{\frac{1}{2}} d_{\lfloor n/2 \rfloor}^{\frac{1}{2}}$$

for all $n \in \mathbb{N}$, $n \geq 2$.

- P. Binev, A. Cohen, W. Dahmen, R. DeVore, G. Petrova, and P. Wojtaszczyk, "Convergence Rates for Greedy Algorithms in Reduced Basis Methods." *SIAM Journal on Mathematical Analysis*, 43 (2011), pp. 1457-1472.
- R. DeVore, G. Petrova, and P. Wojtaszczyk, "Greedy Algorithms for Reduced Bases in Banach Spaces." *Constructive Approximation*, 37 (2013), pp. 455-466.

Putting Everything Together.....

- ▶ $\|\text{MSE}\|_\infty$: $\sigma_n = O\left(d_{\lfloor n/2 \rfloor}^{1/2}\right)$
- ▶ Kolmogorov width: $d_n = O\left(h_n^k\right)$
- ▶ fill distance: $h_n = O\left(n^{-\frac{1}{d}}\right)$

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Conclusion: The sequential, greedy algorithm guarantees

$$\left\| \text{MSE} \left(\hat{f}_n(\cdot) \right) \right\|_\infty = \sigma_n \leq C_k n^{-\frac{k}{d}} \quad \text{for } C_k > 0, \text{ if } M \in \mathcal{C}^k$$

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- ▶ In particular, if $M \in C^\infty$, Gaussian process landmarking guarantees that MSE decays faster than any inverse polynomial in n (at the expense of possibly blowing constants)
- ▶ **Open Question:** Exponential convergence? Lower bound?

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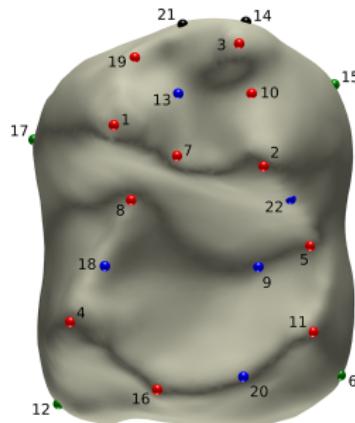
- ▶ Sequential Experimental Design
- ▶ Witten Laplacian
- ▶ Reduced Basis Method

Other Applications

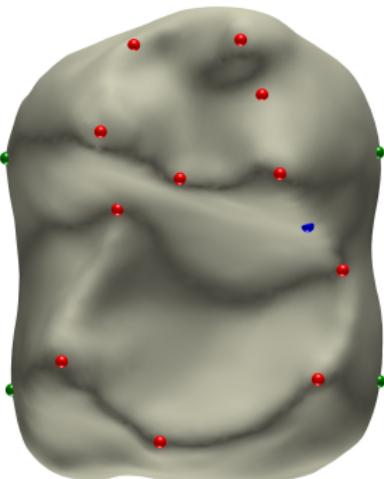
Joint work with **Shahar Z. Kovalsky, Doug M. Boyer, Ingrid Daubechies**

Post-Stories

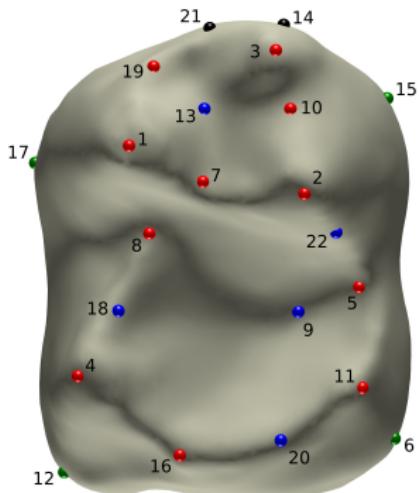
- ▶ R. Ravier, "Algorithms with Applications to Anthropology."
Ph.D. Dissertation, Duke University (2018)
- ▶ Matrix sensing pattern design
- ▶ faster diffusion MRI imaging



Thank You!



(a) Observer Landmarks



(b) First 22 Gaussian Process Landmarks

- T. Gao, S.Z. Kovalsky, I. Daubechies, "Gaussian Process Landmarking on Manifolds." *SIAM Journal on Mathematics of Data Science*, 1(1), 208–236 (2019)
- T. Gao, S.Z. Kovalsky, D.M. Boyer, I. Daubechies, "Gaussian Process Landmarking for Three-Dimensional Geometric Morphometrics." *SIAM Journal on Mathematics of Data Science*, 1(1), 237–267 (2019)